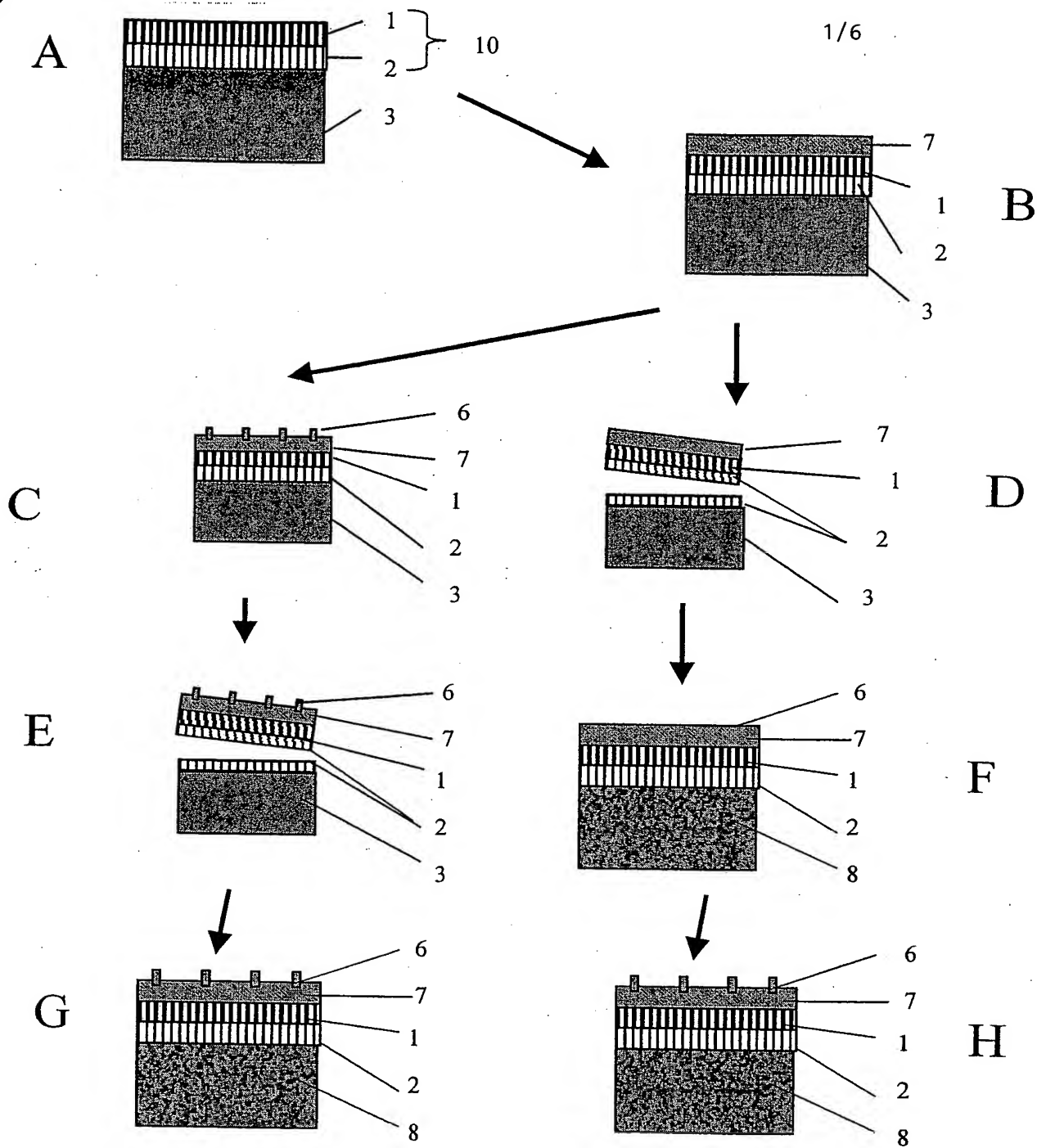




METHOD FOR MAKING THIN FILM DEVICES INTENDED FOR  
SOLAR CELLS OR SILICON-ON-INSULATOR (SOI)  
APPLICATIONS

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REPLACEMENT SHEET



PRIOR ART

Fig. 1

METHOD FOR MAKING THIN FILM DEVICES INTENDED FOR  
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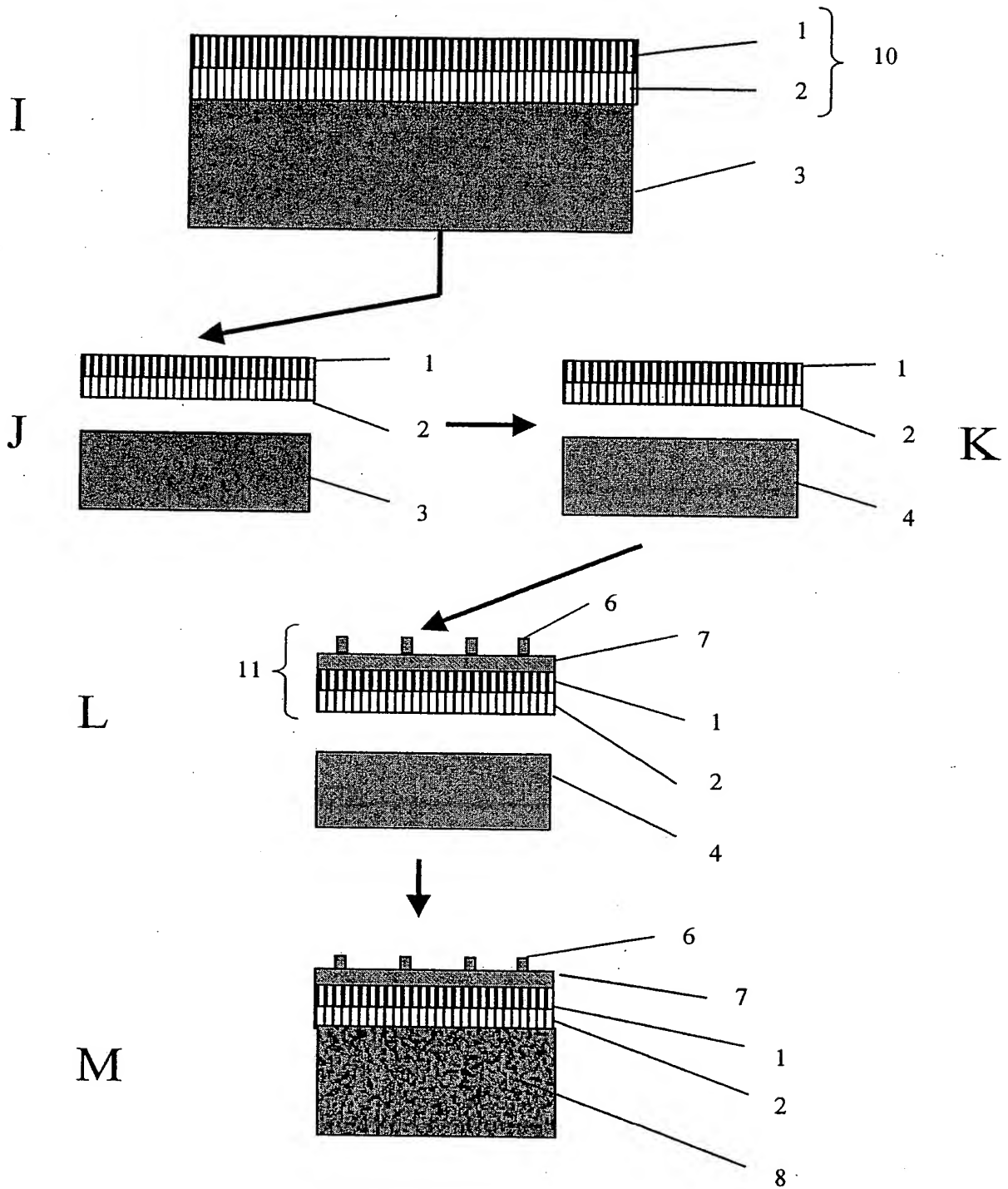


Fig. 2

METHOD FOR MAKING THIN FILM DEVICES INTENDED FOR  
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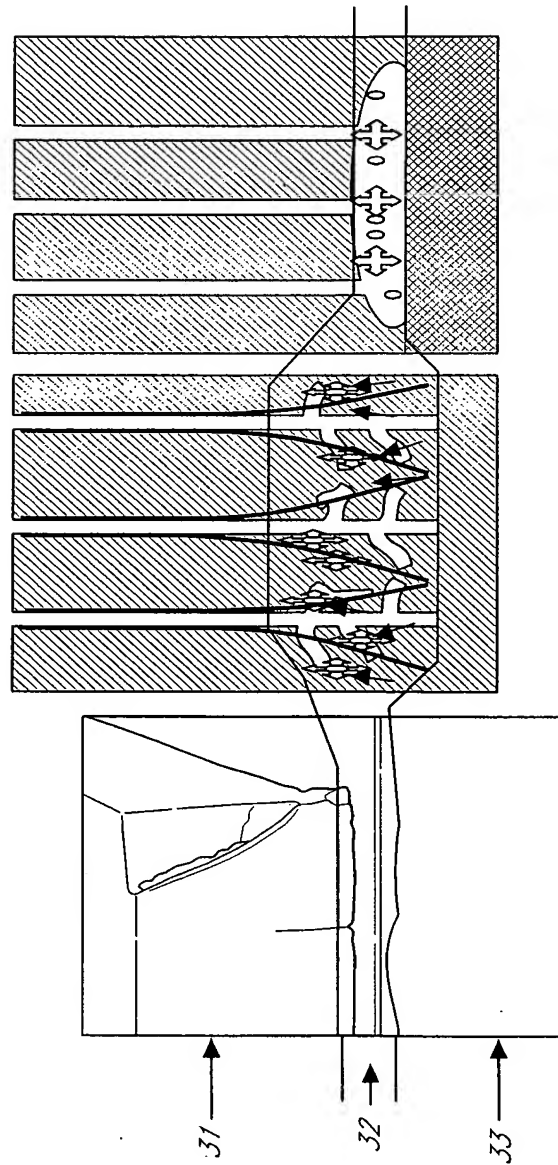


FIG. 3

METHOD FOR MAKING THIN FILM DEVICES INTENDED FOR  
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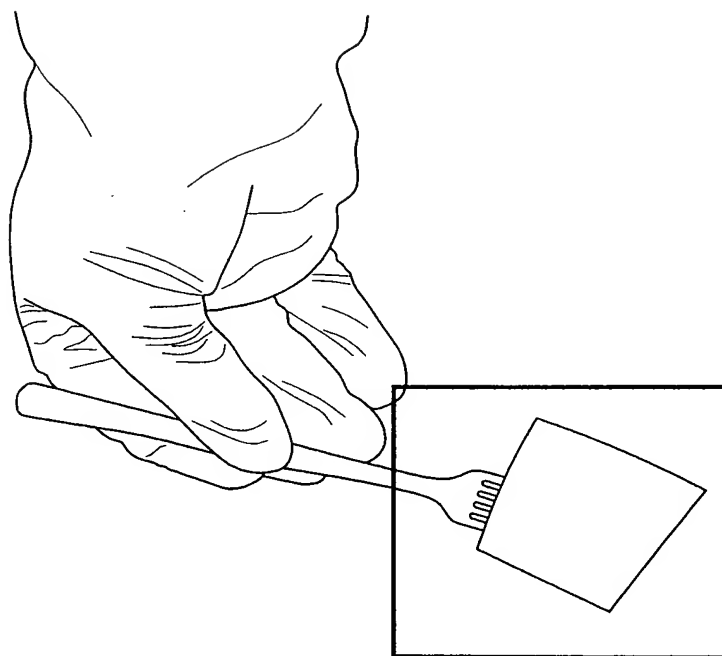
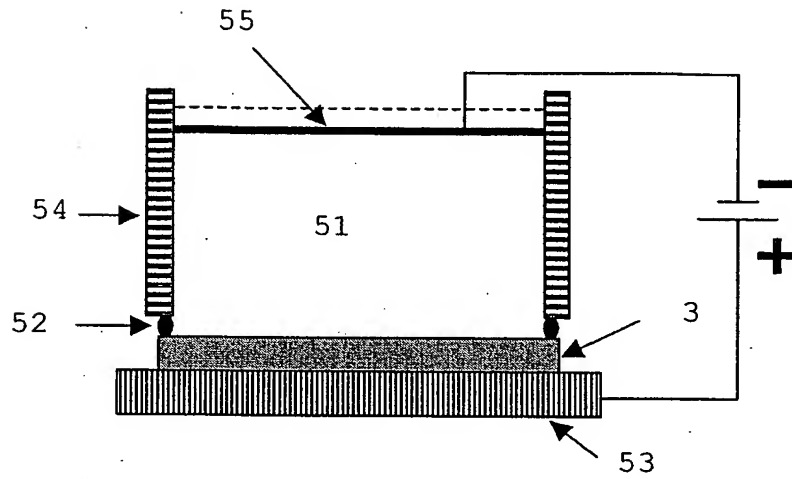


FIG. 4

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PRIOR ART

Fig. 5

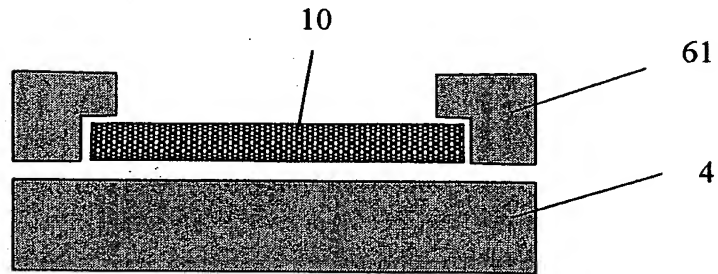


Fig. 6

METHOD FOR MAKING THIN FILM DEVICES INTENDED FOR  
SOLAR CELLS OR SILICON-ON-INSULATOR (SOI)  
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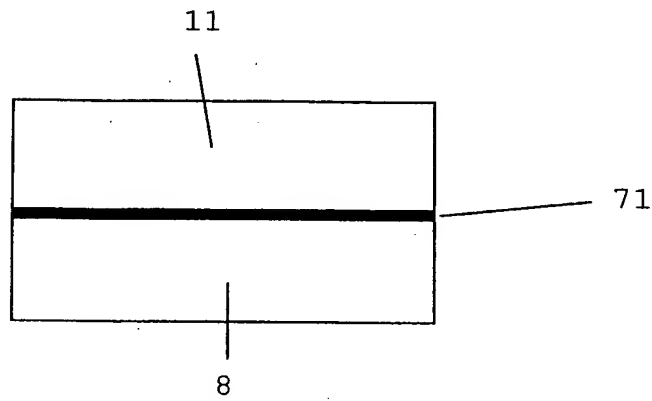


Fig. 7